561 ATTORNEY DOCKET NO.

**PATENT** 



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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Before the Examiner:

Marina V. Plat et al.

Lee, Hsien Ming

Serial No.: 10/079,775

Group Art Unit: 2823

Filed: February 19, 2002

Title: METHOD AND SYSTEM FOR REDUCING ARC LAYER REMOVAL

OF PHOTORESIST

## **AMENDMENT TRANSMITTAL**

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment Under 37 C.F.R. § 1.116, 2 Executed 131 Declarations and Acknowledgment Postcard for the aboveidentified Application.

- No additional fee is required.
- The fee has been calculated as shown below:

## **CERTIFICATION UNDER 37 C.F.R. § 1.8**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on \_\_\_\_\_\_

Signature

Toni Stanley

(Printed name of person certifying)